

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Takeshita et al.
Appl. No. : 10/580,768
Filed : May 25, 2006
For : POSITIVE RESIST
COMPOSITION AND METHOD
FOR FORMING RESIST
PATTERN
Examiner : Eoff, A.
Group Art Unit : 1795

CERTIFICATE OF EPS WEB
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8/20/08

(Date)

Neil S. Bartfield, Ph.D., Reg. No. 39,901

AMENDMENT AND RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed May 23, 2008, please consider the following remarks:

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.